



IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicants: Geun Su Lee et al.
Serial No.: 10/723,029
Filed: November 26, 2003
Title: CLEANING SOLUTION FOR
PHOTORESIST AND METHOD
FOR FORMING PATTERN
USING THE SAME
Group Art Unit: 1751
Examiner: Gregory E. Webb
Attorney Docket No.: 30205/39714

) I hereby certify that this paper is being
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Mail Stop Amendment, Commissioner for
Patents, P.O. Box 1450, Alexandria,
Virginia 22313-1450, on **May 30, 2006**.
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RESPONSE PURSUANT TO 37 CFR § 1.143

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

This paper is presented pursuant to 37 CFR § 1.143 and in response to the April 27, 2006, non-final official action requiring a three-way restriction among the pending claims (i.e., claims 1-23) for examination purposes. The restriction requirement is traversed, and reconsideration and withdrawal of the restriction requirement are respectfully requested in view of the following remarks.

A complete listing of the existing claims is not required (or presented herein) because no changes are being made to the claims, no claims are being canceled, and no claims are being added. *See 37 CFR § 1.121(c).*

The action does not acknowledge the applicants' claim for foreign priority under 35 USC § 119 and the U.S. Patent and Trademark Office's (PTO's) receipt of certified copies of the foreign priority applications, which were filed November 26, 2003. The applicants respectfully request appropriate acknowledgment of each in the next official action.